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(A) Journal papers (SCI/ EI)

1. Y. C. Lee, S. W. Chang, S. H. Chen, S. L. Chen, and H. L. Chen*, "Optical inspection of two-dimensional materials: From mechanical exfoliation to wafer-scale growth and beyond," *Advanced Science,* (2022), 9, 2102128

2. Y. L. Chang, I. C. Lai, L. C. Lu, S. W. Chang, A. Y. Sun, D. Wan*, and H. L. Chen* "Wafer-scale nanocracks enable single-molecule detection and on-site analysis," *Biosensors and Bioelectronics*, 200, (2022) 113920

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4. S. L. Chen, S. W Chang, Y. J. Chen, and H. L. Chen*, "Possible warming effect of fine particulate matter in the atmosphere," *Communications Earth and Environment*, 2, 208 (2021)

5. C. C. Lin, B. J. Chang, S. H. Chen, K. T. Lin, S. W. Chang, W. Y. Chen, B. Y Chen, M. C. Liu, and H. L. Chen*, "Gallium arsenide–based active antennas for optical communication photodetection with robustness to voltage and temperature," *Advanced Optical Materials*, 9, 2100165 (1-12) (2021) DOI: 10.1002/adom.202100165

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9. S. J. Kuo, S. W. Chang, Y. Y. Hui, O. Y. Chen, Y. W Chen, C. C. Lin, Dehui Wan, H. L. Chen*, and H. C. Chang*, "Fluorescent Microdiamonds Conjugated with Hollow Gold Nanoparticles as Photothermal Fiducial Markers in Tissue," *Journal of Materials Chemistry C,* 7, 15197-15207 (2019)

10. K. T. Lin, C. J. Chan, Y. S. Lai*, L. T. Shiu, and H. L. Chen*, "Silicon-Based Embedded Trenches of Active Antennas for High-Responsivity Omnidirectional Photodetection at Telecommunication Wavelengths", *ACS Applied Materials & Interfaces*, Volume 11, Issue 3, 3150–3159, (2019) **(Supplementary Cover 期刊封面)**

11. C-K Ku, P-H Wu, C-C Chung, C -C Chen, K-J Tsai, H-M Chen, Y-C Chang, C-H Chuang, C-Y Wei, C-Y Wen, T-Y Lin, H. L. Chen, Z-Y Lee, J-R Chang, Y-S Wang, D-Y Wang, Bing Joe Hwang, Chun-Wei Chen, "Creation of three-dimensional textured graphene/Si Schottky junction photocathode for enhanced photoelectrochemical efficiency and stability", *Advanced Energy Materials*, 1901022, (2019) **(Back Cover 期刊封面)**

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